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				Application Number	78D- 0	657 616
	INFORMATION DISCLOSURE			Filing Date	-Horewith	9 - 8 - 03
STATEMENT BY APPLICANT			First Named Inventor	Lee, et al.		
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	(use as many sheets as necessary)			Examiner Name	TBD	
Sheet	1	of	1	Attorney Docket Number	TSM03-0587	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.	Document Number Number - Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
y L	1	US-5,221,367	06-22-1993	Chisholm, et al.	
	2	US-5,801,083	09-01-1998	Yu, et al.	
	3	US-6,039,803	03-21-2000	Fitzgerald, et al.	
	4	US-6,107,653	08-22-2000	Fitzgerald	
	5	US-6,245,684	08-12-2001	Zhao, et al.	
	6	US-6,291,321	09-18-2001	Fitzgerald	
	7	US-6,429,061	08-06-2002	Rim	
	8	US-6,503,773	01-07-2003	Fitzgerald	
	9	US-6,509,232	01-21-2003	Kim, et al.	
	10	US-6,518,644	02-11-2003	Fitzgerald	
	11	US-6,544,860	04-08-2003	Singh	
	12	US-6,579,768	06-17-2003	Thwaite, et al.	
17	13	US-6,597,026	07-22-2003	Ogura	
U	14	US-20030034529A1	02-20-2003	Fitzgerald, et al.	
8u	15	US-20030049893A1	03-13-2003	Currie, et al.	

		FOREIG	N PATENT DOCU	IMENTS	•	
Examiner Cite No.1	Cito	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages	70
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Sh	16	SCHLUETER, J., "Trench Warfare: CMP and Shallow Trench Isolation," Semiconductor International, October 1999.		
Sh	17	TARASCHI, G., "Strained Si-on-Insulator Development Accelerates," Compound Semiconductor, April 2003.	_	

Examiner	0-10.	Date 12/2-1-	
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